



Docket No.: M4065.0073/P073
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Donald L. Yates

Application No.: 09/123,430

Art Unit: 2823

Filed: July 28, 1998

Examiner: B. Kebede

For: METHOD OF REDUCING SURFACE
CONTAMINATION IN SEMICONDUCTOR
WET-PROCESSING VESSELS

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 14, 2004 (Paper No. 20040405), finally rejecting claims 1, 6, 7, 9, 10, 12, 15, 17, 18, 20-22, 25-27, 44, 61, 62, 64, 66-71, and 73-77, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.